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IN THE U.S. PATENT AND TRADEMARK OFFICE

November 7, 2001

Applicant(s) : (

Okimitsu YASUDA et al.

For

SULFURIC ACID RYCYCLE APPARATUS

Atty. Docket No.:

OPS Case 555

Assistant Commissioner for Patents

Washington, DC 20231

PRELIMINARY AMENDMENT CANCELLING CLAIMS

Sir:

Prior to calculation of the filing fee in the aboveidentified application, kindly enter the following:

IN THE CLAIMS

Kindly amend Claims 3 and 5-7 as follows:

- 3. (Amended) The sulfuric acid recycle apparatus according to Claim 1, wherein the reaction bath includes therein a plurality of partition plates for changing an advancing direction of the wafer cleaning waste fluid, and an inclination plate positioned at a portion closer to the gas discharge port than the partition plates for allowing the concentrated sulfuric acid to flow along the surface thereof.
- 5. (Amended) The sulfuric acid recycle apparatus according to Claim 1, wherein the reaction bath has a waterdrop storage bath for preventing waterdrop attached to a ceiling surface of the reaction bath from being mixed with the concentrated sulfuric acid.
- 6. (Amended) The sulfuric acid recycle apparatus according to Claim 1, wherein fresh sulfuric acid is supplied to the concentrated sulfuric acid.
- 7. (Amended) The sulfuric acid recycle apparatus according to Claim 2, wherein a heating temperature in the reaction bath ranges from 150° C to 350° C.

Preliminary Amendment Cancelling Claims - Page 2

Pursuant to 37 CFR §1.121, a marked-up version of amended Claims 3 and 5-7 is attached hereto showing the changes made by the current amendment.

REMARKS

This amendment amends Claims 3 and 5-7 to eliminate multiple dependencies so as to reduce the filing fee. Please enter this amendment before calculating the filing fee.

Respectfully submitted,

Dale H. Thiel

DHT/jp

FLYNN, THIEL, BOUTELL & TANIS, P.C. 2026 Rambling Road Kalamazoo, MI 49008-1699 Phone: (616) 381-1156 Fax: (616) 381-5465	Dale H. Thiel David G. Boutell Ronald J. Tanis Terryence F. Chapman Mark L. Maki David S. Goldenberg Sidney B. Williams, Jr. Liane L. Churney Brian R. Tumm Tricia R. Cobb	Reg. Reg. Reg. Reg. Reg. Reg.	No. No. No. No. No. No. No. No.	25 22 32 36 31 24 40 36	072 724 549 589 257 949 694 328
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Encl: Marked-up version of Claims 3 and 5-7

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Claims 3 and 5-7 have been amended as follows:

- 3. (Amended) The sulfuric acid recycle apparatus according to Claim 1—or 2, wherein the reaction bath includes therein a plurality of partition plates for changing an advancing direction of the wafer cleaning waste fluid, and an inclination plate positioned at a portion closer to the gas discharge port than the partition plates for allowing the concentrated sulfuric acid to flow along the surface thereof.
- 5. (Amended) The sulfuric acid recycle apparatus according to any of Claims 1 to 4Claim 1, wherein the reaction bath has a waterdrop storage bath for preventing waterdrop attached to a ceiling surface of the reaction bath from being mixed with the concentrated sulfuric acid.
- 6. (Amended) The sulfuric acid recycle apparatus according to any of Claims 1 to 5Claim 1, wherein fresh sulfuric acid is supplied to the concentrated sulfuric acid.
- 7. (Amended) The sulfuric acid recycle apparatus according to any of Claims 2 to 6Claim 2, wherein a heating temperature in the reaction bath ranges from 150°C to 350°C.